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CONFIRMATION COPY

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**NEC**

NEC Electronics Corporation

VIA FACSIMILE

November 28, 2003

Mr. Howard L. Bernstein  
SUGHRUE MION, PLLC  
2100 Pennsylvania Avenue, NW  
Washington, D.C. 20037-3213  
U.S.A

Re: U.S. Patent Application No. 09/941,744  
Your Ref.: Q64096  
Our File.: 264083/00

Dear Mr. Bernstein:

This is to ask you to prepare and file an Information Disclosure Statement (IDS) for the above-identified applications.

In connection with the counterpart Korean patent application to this US application, the Korean Patent Office issued an Office Action on September 30, 2003, a copy of which is enclosed herewith. As for the prior art reference cited in the Office Action, we are sending it to you by airmail with a confirmation copy of this letter. It would be therefore appreciated if you could arrange to submit the cited reference to the USPTO as an IDS.

Concerning a brief explanation of relevancy of the teachings of the cited prior art reference to the present invention, it is our desire to substitute it with the comments of the Korean Examiner indicated in the Office Action. Since parts representative of Examiner's comments in the Japanese translation of the Office Action are encircled by hand-written wavy line, we would appreciate your arranging to obtain its English translation. Please also note that the mailing date of the Office Action is encircled by another wavy line. If such translation service is not available, please let us know. We will prepare and send it to you.

Very truly yours,

*Masahiko Fujiwara*  
for Masahiko Fujiwara  
General Manager  
Intellectual Asset Division

Enclosures:

- Copy of Office Action
- Each copy of the cited reference (Sent by Airmail)

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